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Docket No. 92478-2600

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Yukihiro Morita et al.

Serial No.: 10/533,605

Filed: April 29, 2005

For: PLASMA DISPLAY PANEL AND
MANUFACTURING METHOD FOR THE
SAME

Examiner: Raabe, Christopher M.

Group Art Unit: 2879

October 19, 2006

Costa Mesa, California 92626

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Mail Stop Amendment
Commissioner for Patents
PO Box 1450
Alexandria, VA 22313-1450

Dear Sirs:

In an attempt to fully comply with the duty of disclosure set forth in 37 C.F.R. §1.56 and in conformance with 37 C.F.R. §§ 1.97 and 1.98, applicant has already brought to the attention of the United States Patent Office the following references, with English abstracts.

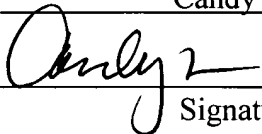
Japanese Patent Application Publication No. 9-208851
Japanese Patent Application Publication No. 2000-129161
Japanese Patent Application Publication No. 7-192630
Japanese Patent Application Publication No. 9-167566

To further assist the Examiner, applicant has now had prepared full English translations of these references, copies of which are attached hereto, along with a new form PTO-A820.

If there are any questions in the prosecution of this matter, the undersigned attorney would appreciate a telephone conference.

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail in an envelope addressed to Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on October 19, 2006.

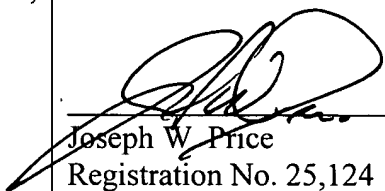
By: Candy Neu


Signature

Dated: October 19, 2006

Very truly yours,

SNELL & WILMER L.L.P.



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INFORMATION DISCLOSURE CITATION <i>(Use several sheets if necessary)</i>				Docket Number (Optional)		Application Number		
				92478-2600		10/533,605		
				Applicant(s)				
				Yukihiro Morita, et al.				
				Filing Date		Group Art Unit		
				April 29, 2005		2879		
U. S. PATENT DOCUMENTS								
EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE	
U. S. PATENT APPLICATION PUBLICATIONS								
EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE	
FOREIGN PATENT DOCUMENTS								
	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO
		HO9-208851	1.30.1996	Japan			X	
		2000-129161	10.21.1998	Japan			X	
		HO7-192630	12.27.1993	Japan			X	
		HO9-167566	12.15.1995	Japan			X	
OTHER DOCUMENTS <i>(Including Author, Title, Date, Pertinent Pages, Etc.)</i>								
EXAMINER				DATE CONSIDERED				
EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.								